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PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#2

In re Application of:

TOSHIHIRO YAMASHITA ET AL.

Application No.: 10/050,787

Filed: January 18, 2002

For: SPUTTERING METHOD
AND SPUTTERING
APPARATUS

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: Examiner: Not Yet Assigned

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: Group Art Unit: Not Yet Assigned

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March 11, 2002

Commissioner for Patents
Washington, D.C. 20231

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
08/768,609	11/18/99	1762
09/294,367	04/20/99	1764
09/822,191	04/02/01	1762
09/844,071	04/30/01	1753
08/916,540	08/22/97	1763

A copy of each cited Application is enclosed.

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CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No. 24947

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